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# Fax

**To:** Examiner Theresa T. Doan **From:** Joanne Ryan  
**Fax:** 1-703-872-9306 **Pages:** 6 (including cover)  
**Phone:** 1-571-272-1704 **Date:** April 1, 2005  
**Re:** 10/800,348 **CC:** [Click here and type name]  
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PLEASE SEE ATTACHED RESPONSE TO OFFICE ACTION

Serial No.: 10/800,348

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Tenko Yamashita

Serial No.: 10/800,348

Filed: 03/12/2004

Title: SILICON-ON INSULATOR (SOI) SUBSTRATE HAVING DUAL SURFACE  
CRYSTALLOGRAPHIC ORIENTATIONS AND METHOD OF  
FORMING SAME

Art Unit: 2814

Examiner: Theresa T. Doan

Confirmation No.: 9885

Docket No.: 50T5690.01

Via Facsimile 703-872-9306  
Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

In response to the Office Action dated March 2, 2005, kindly consider the following  
response to the outstanding restriction requirement: